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PATENT Customer No. 22,852 Attorney Docket No. 03180.0343

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re A	pplication of:	)
	Masafumi ASANO et al.	) 
Application No.: 10/725,571		) Group Art Unit: 1756 )
		, ) Examiner: Stephen D. Rosasco
Filed:	December 3, 2003	) \
For:	RETICLE SET, METHOD FOR	Confirmation No.: 5144
	DESIGNING A RETICLE SET, EXPOSURE MONITORING METHOD,	) )
	INSPECTION METHOD FOR RETICLE	)
	SET AND MANUFACTURING METHOD	)
	FOR A SEMICONDUCTOR DEVICE	)

## **Mail Stop Amendment**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## **REPLY TO OFFICE ACTION**

In reply to the Office Action mailed February 3, 2006, the period for response to which extends through May 3, 2006, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper beginning on page 2.

Remarks follow the amendment section of this paper, beginning on page 10.